

Electronic Acknowledgement Receipt

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Title of Invention:	DEEP TRENCH FORMATION IN SEMICONDUCTOR DEVICE FABRICATION
First Named Inventor:	June Cline
Customer Number:	30449
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Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Request for Certificate of Correction	BUR920040122US1_Certof Correction_10-04-06.pdf	39521	no	1

Warnings:	
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